Notice of References Cited Application/Control No. 10/612,074 Examiner Michelle Estrada Applicant(s)/Patent Under Reexamination CHA, JAE HAN Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-6,399,992	06-2002	Matsumoto et al.	257/369
	В	US-6,436,791	08-2002	Lin et al.	438/424
	С	US-6,682,967	01-2004	Matsumoto et al.	438/224
	D	US-4,926,233	05-1990	Hutter, Louis N.	257/370
	Ε	US-6,528,379	03-2003	Takada et al.	438/322
	F	US-			
	G	US-			
	Н	US-			
	ı	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 02203549 A	08-1990	Japan	TANAKA et al.	H01L 21/76
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NON-PATENT DOCUMENTS

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